

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ikuo Nishimoto et al.  
Application No. : 10/538,980  
Date of Filing : June 14, 2005  
Title : APPARATUS AND METHOD OF EXPOSING LIGHT  
TO A SEMICONDUCTOR DEVICE HAVING A  
CURVED SURFACE  
Confirmation No. : 9472  
Examiner : Mathews, Alan A.  
TC/Art Unit : 2851  
USPTO Customer No. : 26707  
Attorney Docket No. : 981045.90011

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RESPONSE UNDER 37 C.F.R. §1.111

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 13, 2006,  
Applicant(s) respectfully request the Examiner to reconsider and  
further examine the Application in view of the amendments and/or  
comments as set forth below.

Amendments to the Specification: None.

Amendments to the Claims: Begin on page 2.

Amendments to the Drawings: None.

Remarks: Begin on page 8.